



**ELECTRONIC COPY**

LG652419272  
Report verification at igi.org



September 12, 2024

IGI Report Number **LG652419272**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

Measurements **8.08 X 7.80 X 5.35 MM**

**GRADING RESULTS**

Carat Weight **3.21 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

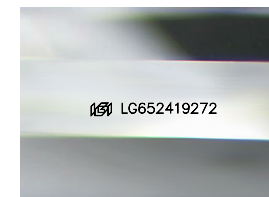
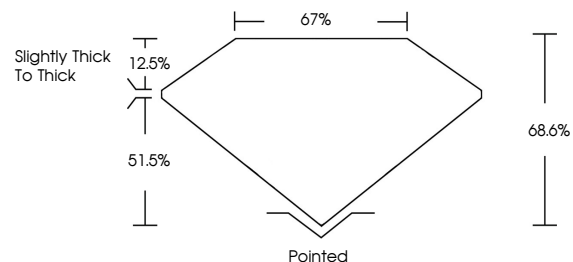
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG652419272**

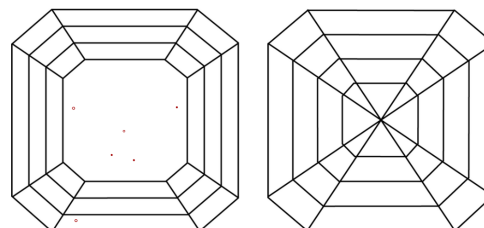
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

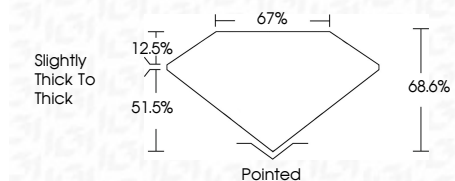
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



September 12, 2024  
IGI Report No LG652419272  
**SQUARE EMERALD CUT**  
8.08 X 7.80 X 5.35 MM  
3.21 CARATS  
Color Grade **G**  
Clarity Grade **VS 1**  
Depth **68.6%**  
Table **67%**  
Girdle **Slightly thick to thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG652419272**

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